

Notice of References Cited	Application/Control No. 10/685,940		Applicant(s)/Patent Under Reexamination RENTSCHLER ET AL.	
	Examiner Hong C. Kim		Art Unit 2185	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,255,241	10-1993	Stern et al.	365/226
*	B	US-6,011,751	01-2000	Hirabayashi, Osamu	365/236
*	C	US-6,060,916	05-2000	Park, Chan-seok	327/99
*	D	US-6,205,046	03-2001	Maesako, Taketo	365/120
*	E	US-6,525,565	02-2003	Young et al.	326/46
*	F	US-6,615,345	09-2003	LaBerge, Paul A.	713/100
*	G	US-6,694,416	02-2004	Thomann et al.	711/169
*	H	US-6,806,733	10-2004	Pan et al.	326/41
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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